## **Other organisations from Romania**

#### Institute for Electrical R&D National Engineering ICPE - CA, www.icpe-ca.ro

#### Main R&D directions:

• Advanced Materials: functional/multifunctional, crystalline and nanostructured materials and composites

• New sources of energy (wind energy, solar energy, fuel cells, biogas, hydro-energy, hydrogen storage): conversion, saving and recovery

 Micro-Electromechanical technologies and systems: nonconventional electrical engineering

MNT.ERA-NET project "Minisupercapacitors technology, based on hybrid CNT/CNF electroactive polymer networks", 2012 - 2015



Positive electrod -polypyrrole deposited by cyclic voltammetry on CNTs

#### National Institute of R&D in Mechatronics and Measurement Technique INCDMTM www.incdmtm.ro

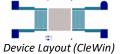
Areas of expertise: Precision Mechanics. Mechatronics and Cvber-MixMechatronics. Adaptronics Intelligent Integronics, and Measurement Technique industries.

Research results with industrial and medical applications: computer-aided intelligent complex measuring and integrated control equipment; quality control equipment; biomedical devices and systems.

Industrial cooperation: processing and machinery industry, automotive domain.

#### ROMQUARTZ S.A., www.minatech.ro/romquartz

Project "SH-SAW sensor fabrication on LiTaO<sub>2</sub> for mass detection in liquid media"





Packaging

### **Danubian Region**

## Bulgaria

Institute of Solid State Physics; Institute of Optical Materials & Technologies; 
University of Sofia; Sofia Tech Park" JSC, Micro Nano Lab *Companies:* • Multicoats: • Innovative Solutions Bulgaria Ltd.; Smartcom (MEMS design, modeling and characterization); • NANOTECH GROUP

# **Czech Republic**

CEITEC Central **European Institute of** Technology



CEITEC Nano is Czech Republic's largest cleanroom nanocentre: 61 research groups, 25000 m<sup>2</sup> of new laboratories; 10 core facilities.

# Hungary

 Budapest University of Technology and Economics, Dept. of Electron Devices



Institute of Technical Physics & Material Sciences, Centre for Energy Research; Institute for Solid State Physics and Optics

## **Republic of Moldova**

- National Center for Materials Study and Testing (NCMST) - Technical University of Moldova
- Ghitu Institute of Electronic Engineering and Nanotechnologies
- ELIRI company

#### Full info: www.imt.ro/MMS2017 RO.pdf

Contact: Dr. Adrian Dinescu, adrian.dinescu@imt.ro IMT Bucharest CEO and President of the Board





# **IMT Bucharest**

National Institute for R&D in **Microtechnologies** 

On behalf of Romania and "Danubian" region



Romania is participating to "Micromachine Summit" since 2007 (Venice, Italy)

#### IMT research fields:

- micro and nanoelectronic devices
- micro and nanophotonics
- micro and nanodevices for medical applications (BIOMEMS)
- micro-electro-mechanical systems (MEMS) including microtraductors, micro and nanofluidics
- advanced materials and nanotechnologies

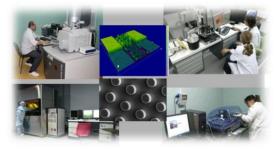




# Offer of services

### IMT centre for MIcro- and **NAnoFABrication (IMT-MINAFAB)** www.imt.ro/MINAFAB

- X-ray diffraction characterization for thin films
- DNA/protein microarray slide analysis Electrochemical analyses, ultra-high resolution field emission SEM imaging • Studies of mechanical properties of materials on small scales or near surfaces with high spatial resolution • Scanning Probe Microscopy characterization • Confocal, AFM, Near field optical microscopy, Raman scanning spectroscopy and imaging • Technological processes in inert atmosphere • RAMAN Spectroscopy • Spectroscopic Ellipsometry



Facility for micro-nanostructuring of devices and systems

• Technological services for micro-nano devices and systems; • Masks fabrications; • Isotropic silicon etching; Chopping gas method (Bosch process) for anisotropic silicon etching; Cryogenic method for anisotropic silicon etching; • Dry etching of Si, SiO<sub>2</sub>, Si<sub>3</sub>N<sub>4</sub>; Polymer etching; Surface modification in plasma; • Nano-scale patterning of various substrates, electron beam induced deposition and etching.

# **IMT Bucharest**

# **Experimental Infrastructure**

#### **Research Centre for Integrated Systems Nanotechnologies and Carbon Based** New! **Nanomaterials**

**CENASIC** (completed - 2015)

• Epitaxial growth of nitride compounds on various substrates;

• Growth of graphene / carbon nanotubes;

- · Deposition of oxide ultra-thin films using ALD technology;
- Thin layer deposition using RF magnetron sputtering;
- Wet oxidation (Hydrox);
- Boron diffusion; Phosphorous diffusion;
- Thermal annealing;
- FT-IR investigations under vacuum conditions, FT-Raman;

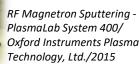
• High performance computing: Numerical modeling/simulation for: Multiphysics; Quantum mechanics; Molecular dynamics



Plasma Enhanced Chemical Vapor Deposition (PECVD) -Nanofab 1000/ Oxford Instruments Plasma Technology, Ltd./2015

Molecular Beam Epitaxy (MBE) - COMPACT 21 DZ/Riber Inc./2015





# **International cooperation**

HORIZ N 2020

- "Integrated Components for Complexity Control in affordable electrified cars - 3CCar"; ECSEL, 2015-2018, http://www.3ccar.eu/
- □ "Crossbar of Microelectromechanical Selectors and Non-Volatile Memory Devices for Neuromorphic Computing – SelectX"; Marie Skłodowska-Curie Actions - Individual Fellowship, 2016-2018, http://www.imt.ro/selectX

# M-era.Net

- "PiezoMEMS Piezoelectric MEMS for efficient" energy harvesting", 2015-2018
- □ "PhotoNanoP High photoconductive oxide films functionalized with GeSi nanoparticles for environmental applications", 2015-2018

# **Gesa** European Space Agency

- □ "Microwave filters based on GaN/Si SAW resonators, operating at frequencies above 5GHz"
- "0-level encapsulation of reliable MEMS switch" structures for RF applications"
- "PROBA-3 Coronagraph System"

### The Danube Nano Micro Facility Network (DNMF net)

Expected start date: 1<sup>st</sup> of June 2017. Partners:

 Karlsruhe Institute of Technology (KIT), Germany -Karlsruhe Nano Micro Facility (KNMF) - coordinator; • CEITEC Nano, Central European Institute of Technology, Czech Republic; • Budapest University of Technology and Economics, Department of Electron Devices (BME-EET), Hungary; • IMT-MINAFAB, National Institute for Microtechnologies IMT Bucharest, Romania; • National Center for Materials Study and Testing (NCMST), Republic of Moldova

